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PATENT  
Attorney Docket No.: SAM-0526  
Customer No.: 29344

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Ki Hwan Park, *et al.*      Examiner: El Arini, Zeinab  
Serial No.: 10/796,507      Group Art Unit: 1746  
Filing Date: March 9, 2004  
Title: SYSTEM FOR RINSING AND DRYING SEMICONDUCTOR SUBSTRATES  
AND METHOD THEREFOR

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the United States Post Office as First Class Mail on the date indicated below in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

9.30.05

Date



Vanessa Marakas

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Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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TRANSMITTAL LETTER

Sir:

Enclosed herewith for filing in the above-identified patent application please find the following listed items:

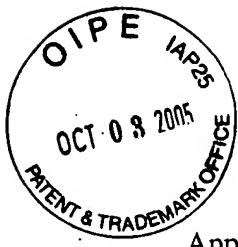
1. Supplemental Information Disclosure Statement;
2. Form PTO-1449 and copy of cited reference AL; and
3. Return Postcard.

In connection with the foregoing matter, please charge any additional fees which may be due, or credit any overpayment, to Deposit Account Number 50-1798. A duplicate copy of this letter is provided for this purpose.

Respectfully submitted,

Date: September 30, 2005  
Mills & Onello, LLP  
Eleven Beacon Street, Suite 605  
Boston, Massachusetts 02108  
Telephone: (617) 994-4900  
Facsimile: (617) 742-7774

  
Anthony P. Onello, Jr.  
Registration Number 38,572  
Attorney for Applicants



PATENT  
Attorney Docket No.: SAM-0526

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Ki Hwan Park, et al.

Examiner:

El Arini, Zeinab

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9.300X

Date

Vanessa Marakas

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement is submitted:

- [ ] under 37 CFR 1.129(a), or  
(First/Second submission after Final Rejection)
- [ ] under 37 CFR 1.97(b), or  
(Within three months of filing national application other than a CPA under §1.53(d); or within three months of date of entry of the national stage in international application; or before mailing date of first Office Action on the merits; or before mailing date of first Office Action after filing RCE under §1.114, whichever occurs last)
- under 37 CFR 1.97(c) together with either:
- [ ] a Statement under 37 CFR 1.97(e), as checked below, or
- [ ] the \$180.00 fee under 37 CFR 1.17(p), or  
(After the 37 CFR 1.97(b) time period, but before final action or notice of allowance, or other action which closes prosecution, whichever occurs first)
- [ ] under 37 CFR 1.97(d) together with:
- [ ] a Statement under 37 CFR 1.97(e), as checked below, and
- [ ] the \$180.00 fee set forth in 37 CFR 1.17(p).  
(Filed after final action or notice of allowance, whichever occurs first, but before payment of the issue fee)

Applicant(s): Ki Hwan Park, *et al.*  
Serial No.: 10/796,507

Statement Under 37 C.F.R. 1.97(e)

- [X] Each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.
- [ ] No item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, after making reasonable inquiry, was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of this Information Disclosure Statement.

Enclosed herewith is form PTO-1449:

- [X] Copies of cited references are enclosed.
- [ ] Copies of cited references are enclosed except those entered in prior application, U.S. Serial No. \_\_\_\_\_, and references that are not required to be submitted under 37 CFR 1.98.
- [ ] The listed references were cited in a counterpart foreign application.

Concise Explanation Requirement (non-English references):

- [X] The "concise explanation" requirement under 36 CFR 1.98(a)(3)(i) for reference AL is satisfied by:

- [ ] the explanation provided on the attached sheet.
- [ ] the explanation provided in the Specification.
- [X] abstract.

It is requested the information disclosed herein be made of record in this application.

Applicant(s): Ki Hwan Park, *et al.*  
Serial No.: 10/796,507

Method of payment:

- [ ] Enclosed is a check in the amount of \_\_\_\_\_.
- [ ] Please charge Deposit Account of 50-1798 in the amount of \_\_\_\_\_.
- [ ] Two duplicate copies of this Statement are enclosed.
- Please charge any deficiency in fees and credit any overpayment to Deposit Account No. 50-1798.

Respectfully submitted,

Date: September 30, 2002  
Mills & Onello, LLP  
Eleven Beacon Street, Suite 605  
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Telephone: (617) 994-4900  
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Anthony P. Onello  
Anthony P. Onello, Jr.  
Registration Number 38,572  
Attorney for Applicants



Sheet 1 of 1

Sup. Form PTO-1449

INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION

(Use several sheets if necessary)

Docket Number (Optional) <b>SAM-0526</b>	Application Number <b>10/796,507</b>
Applicant <b>Ki Hwan Park, et al.</b>	
Filing Date <b>March 9, 2004</b>	Group Art Unit <b>1746</b>

U. S. Patent Documents

EXAMINER INITIALS		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	AL	2003-0063229	07/28/03	Korea	H01L	21/304		X
	AM							
	AN							
	AO							
	AP							
	AQ							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

AR	
AS	
AT	

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy with next communication to applicant.